

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Chi-Chun Chen et al.      § Docket No.: 2001-1448 / 24061.431  
Application No.: 10/666,359      § Customer No.: 42717  
Filing Date: September 19, 2003      § Confirmation No.: 8170  
Entitled: METHOD OF FORMING AN      § Examiner: Smith, Francis P.  
ULTRATHIN NITRIDE/OXIDE STACK AS A      §  
GATE DIELECTRIC      §  
§ Art Unit: 4151

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

POWER OF ATTORNEY AND CORRESPONDENCE ADDRESS INDICATION  
FORM BY ASSIGNEE OF ENTIRE INTEREST INCLUDING CERTIFICATION FOR TAKING  
ACTION BY ASSIGNEE UNDER 37 CFR 3.73(b)

As a representative of the Assignee, Taiwan Semiconductor Manufacturing Company, Ltd., I hereby appoint:

X Practitioners associated with the Customer Number 42717,

as my attorneys and/or agents to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

Please address all correspondence and telephone calls regarding this application to:

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The undersigned representative of the Assignee certifies that Taiwan Semiconductor Manufacturing Company, Ltd. is the assignee of the entire right, title and interest in the above-identified patent application by virtue of an assignment from the inventor(s). A copy of the assignment or other documents in the chain of title is attached.

The undersigned (whose title is supplied below) is authorized to act on behalf of the Assignee.

April 9, 2008  
Date

Taiwan Semiconductor Manufacturing Company, Ltd.  
Assignee

[Signature]  
Signature

Printed Name: David W. Su

Title: Director, IP Division